IN THE UNITED STATES PATERIAL ADEMARK OFFICE

Applicant: Yi-Nan CHEN, Tieb-Bhiang WU,

Filed: 7/16/2003

Appl. No.: 10/620,869

Feng-Chuan LIM

Examiner:

Trinh, Hoa B

Conf. No.: 9126

Art Unit: 2814

Title: SEMICONDUCTOR DEVICE HAVING TRENCH TOP ISOLATION LAYER

AND METHOD FOR FORMING THE SAME

Date: September 1, 2004

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

FEE(S) TRANSMITTAL AND INFORMATION DISCLOSURE STATEMENT **COVER SHEET**

Sir:

Attached please find:

- 1) Form PTO-2038 (1 page), authorizing the Commissioner to charge the issue fee, publication fee, and the petition fee under 37 C.F.R. 1.17(p);
- 2) Form PTOL-85 Part B Fee(s) Transmittal (1 page);
- 3) Information Disclosure Statement with Certification and Petition for Consideration under 37 C.F.R. 1.97 (2 pages).
- 4) Form PTO/SB/08A&B Modified (1 page)
- 5) A copy of each cited reference;
- 6) An English-language translation for each foreign reference;
- 7) A copy of the foreign office action disclosing the cited reference(s); and
- 8) Return receipt postcard.

If any additional fee is required, please charge deposit account No. 502447.

Respectfully submitted,

Nelson A. Quintero Attorney for Applicant Reg. No. 52,143 Customer No. 34,283

Telephone: (310) 401-6180